

| Ref # | Hits | Search Query | DBs | Default Operator | Plurals | Time Stamp |
|-------|------|--|--|------------------|---------|------------------|
| L1 | 872 | (438/510).CCLS. | US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB | OR | OFF | 2005/07/10 15:26 |
| L2 | 1243 | (438/710).CCLS. | US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB | OR | OFF | 2005/07/10 15:37 |
| L3 | 608 | (148/33).CCLS. | US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB | OR | OFF | 2005/07/10 15:43 |
| L4 | 1 | semiconductor substrate.clm. and (hollow microsphere.clm. or hollow microphsteres. clm.) | US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB | ADJ | ON | 2005/07/10 15:43 |

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| <i>DB=PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD; PLUR=YES; OP=ADJ</i> | | | |
| <input type="checkbox"/> | L2 | coated hollow microsphere.ti. | 4 |
| <input type="checkbox"/> | L1 | coated hollow microsphere | 23 |

END OF SEARCH HISTORY